

07-09-08

(15) 1792



Patent  
Attorney Docket 4439

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Nobuhiro Hayashi, Takayoshi Hirono )  
Isao Tada, Atsushi Nakatsuka )  
  )  
Application No.: 10/574,715                         )  
  )  
Filed: March 27, 2006                                 )  
  )  
For: Vacuum Evaporation Deposition Method         )  
of the Winding Type and Vacuum                    )  
Evaporation Deposition Apparatus of the         )  
Same    )

Smith, Francis P.  
Patent Examiner  
Art Unit 1792

Pittsburgh, Pennsylvania

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment is filed in response to the Non-Final Office Action dated April 14, 2008.

Kindly consider the following amendments to the specification and the following remarks.